

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Tatsuhiko SHIBUYA et al.

Serial No. 09/302,471

Filed April 30, 1999

SILICA-BASED COATING FILM ON  
SUBSTRATE AND COATING SOLUTION  
THEREFOR



Docket No. 00774/98-129 TOK/US

Group Art Unit 1755

Examiner D. Brunsman

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of  
September 18, 2000.

The fee of \$110.00 is

- ☒ submitted herewith.  
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.
- ☐ Small entity status of this application is established by the verified statement under 37  
CFR 1.9 and 1.27 which  
☐ is enclosed.  
☐ has been previously submitted.

Respectfully submitted,

Tatsuhiko SHIBUYA et al.

By Matthew Jacob  
Matthew Jacob  
Registration No. 25,154  
Attorney for Applicants

MJ/pjm  
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January 8, 2001

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